

Obducat receives order for an EITRE® 6 NIL-system from a Canadian University

OBDUCAT AB (publ) subsidiary Obducat Technologies AB, a leading supplier of system solutions for lithography processing, has received an order from a Canadian University, for the supply of a EITRE 6 NIL-system as well as a spin coater and hotplate. The order value amounts to approx. 3,4 MSEK.

The lithography systems will be installed in the cleanroom facilities of the University. The system will be used for internal reasearch within the area of MEMS technology.

Delivery is planned for the first quarter 2019.

This is information that Obducat AB (publ.) is obliged to make public pursuant to the EU Market Abuse Regulation. The information was submitted for publication, through the agency of the contact person set out below, on September 20^{th} , 2018 at 13.00 CET.

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About Obducat AB (publ)

Obducat AB (publ) is an innovative developer and supplier of technologies, products and processes used for the production and replication of advanced micro and nano structures. Obducat's products and services serve the demands of companies within the LED, OLED, semiconductor, displays, biomedical and MEMS industries. Obducat's technologies include nano imprint technology, coating technology and wet processing technology. Obducat has offices in Sweden, Germany and China and the headquarter is located in Lund, Sweden. Obducat's class B shares and preferential class B shares are publicly traded on the Swedish NGM Equity stock exchange. Read more at www.obducat.com.